

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/822,775	ISOBE, SHINICHIRO	
Examiner	Art Unit	
Jezia Rilev	1637	

	SEARCHED			
Class	Subclass	Date	Examiner	
435	6			
536	23.1 24.3			
536	26.6	9/17/2005	JR	
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
435	,6				
536	23.1 24.3				
536	26.6	9/17/2005	JR		

SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
STIC structure search enclosed	9/1/2005	JR
STN search enclosed	9/6/2005	JR
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